

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:	§	Attorney Docket No.
Hsien-Wei Chen, et al.	§	2003-1410 / 24061.193
	§	
Serial No.: 10/801,475	§	Customer No. 42717
	§	
Filed: March 16, 2004	§	Group Art Unit: 2822
	§	
For: SYSTEM FOR HEAT	§	Examiner: Monica Lewis
DISSIPATION IN	§	
SEMICONDUCTOR DEVICES	§	Confirmation No.: 1783
	§	
	§	Notice of Allowance: 01-02-2008

**Mail Stop Issue Fee**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

I hereby certify that this correspondence (including any listed enclosures) is being electronically filed in the United States Patent and Trademark Office via the EFS-Web system on January 17, 2008.

  
Linda Ingram

**AMENDMENT UNDER 37 CFR §1.312**

On January 2, 2008, the Patent Office issued a Notice of Allowance, accompanied by a Notice of Allowability that includes a drawing objection, and a requirement for a corrected drawing. This paper is being submitted to document a telephone interview with the Examiner, and to resolve the drawing objection.